



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

CONFIRMATION NO. 3236

Bib Data Sheet

SERIAL NUMBER 10/052,534	FILING DATE 01/23/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 33082M115
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Takayuki Toshima, Nirasaki-Shi, JAPAN;
Takehiko Orie, Nirasaki-Shi, JAPAN;

** CONTINUING DATA *MK (NONE)*

** FOREIGN APPLICATIONS *MK (verified)*

JAPAN 2001-015027 01/23/2001
JAPAN 2001-150283 05/21/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 02/20/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 33	TOTAL CLAIMS 34	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>[Signature]</i>	INITIALS <i>MK</i>		

Verified and
Acknowledged

ADDRESS
00441
SMITH, GAMBRELL & RUSSELL, LLP
1850 M STREET, N.W., SUITE 800
WASHINGTON, DC
20036

TITLE
Substrate processing apparatus and substrate processing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
------------	---	--